IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Satoshi MORIYA Art Unit: 2833

Application No.: 10/538,744 Examiner: Lee, K. S.

Title: RESISTIVE MATERIAL, RESISTIVE ELEMENT, RESISTOR AND

METHOD FOR MANUFACTURING RESISTOR

International Application No.: PCT/JP2003/016013
International Filing Date : December 15, 2003
Priority Date : December 16, 2002
U.S. Filing Date : June 14, 2005

Mail Stop PCT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to his duty of good faith and candor as set forth in 37 CFR 1.56(a), applicant requests that the reference cited on attached form PTO-1449 be considered by the Examiner.

Enclosed is one new reference that was cited and discussed in a communication from the Japanese Patent Office in a counterpart case (Japanese Application No. 2002-363363).

Please note that the English abstract of this reference is enclosed.

This Statement is being filed under 37 CFR 1.97(b) prior to the mailing date of a first Office Action on the merits.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached at the telephone number listed below. All correspondence should continue to be directed to our address below.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Information Disclosure Statement Application No.: 10/538,744

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Respectfully submitted,

Date: September 16, 2009

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